

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Hiroyuki NAGASAKA

Group Art Unit: 2882

Application No.: 10/589,962

Examiner:

C. RIDDLE

Filed: August 18, 2006

Docket No.: 128675

For:

EXPOSURE METHOD, EXPOSURE APPARATUS, EXPOSURE SYSTEM AND DEVICE

MANUFACTURING METHOD

## NOTICE OF APPEAL TO THE BOARD OF PATENT APPEALS AND INTERFERENCES

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Applicant hereby appeals to the Board of Patent Appeals and Interferences from the Decision of the Primary Examiner dated June 22, 2011.

The \$540.00 Appeal Fee (\$270.00 Small Entity) is:

 $\boxtimes$ Enclosed (Check No. 240361)

 $\Box$ Not required (fee paid in prior appeal in this application with no Board Decision on the merits).

In the event of any underpayment or overpayment, please debit or credit Deposit Account No. 15-0461 as needed in order to effect proper filing of this Notice of Appeal.

Respectfully submitted,

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Date: September 22, 2011

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DEPOSIT ACCOUNT USE **AUTHORIZATION** 

Please grant any extension necessary for entry of this filing; Charge any fee due to our Deposit Account No. 15-0461

09/26/2011 LNGUYEN1 00000021 10589962 549.00 OP 01 FC:1401